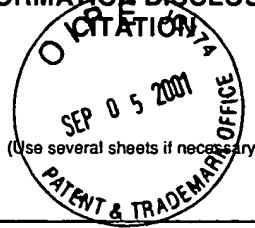


## **INFORMATION DISCLOSURE**

ATTY. DOCKET NO.

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925-203

09/898,082

**APPLICANT**

SUGA

**FILING DATE**

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**GROUP**

July 5, 2001

2812

U.S. PATENT DOCUMENTS

## FOREIGN PATENT DOCUMENTS

## TRANSLATION

**OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)**

JN U.S. Patent Application 09/548,916, filed April 13, 2000 entitled "Semiconductor Device and Manufacturing Method Therefor"

\*Examiner

JOSEPH NGUYEN

**Date Considered**

3/12/02

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

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Form PTO-FB-A820 (Also PTO-1449)